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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of: **IJIMA, Takahiro, et al.**

Group Art Unit: **2829** (expected)

Serial No.: **10/709,912**

Examiner: **Scott B. Geyer** (expected)

Filed: **June 4, 2004**

P.T.O. Confirmation No.: 3911

For: **SEMICONDUCTOR PACKAGE, METHOD OF MANUFACTURING THE SAME,
AND SEMICONDUCTOR DEVICE**

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 CFR 1.97(b)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 8, 2004

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-1449. One copy of each of these documents is attached.

No fee or certification is required in connection with this Information Disclosure Statement, since it is being submitted prior to the issuance of a first official action on the merits or expiration of the three month period following the filing date or the entry of the national stage of the above-captioned application.

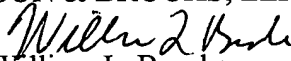
The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

U.S. Patent Application Serial No. 10/709,912
Information Disclosure Statement

The Commissioner is authorized to charge our Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449 and references (1)



INFORMATION DISCLOSURE CITATION PTO-1449	Atty. Docket No. 021083A	Serial No. 10/709,912
	Applicant(s): IIJIMA, Takahiro, et al.	
	Filing Date: June 4, 2004	Group Art Unit: 2829

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					
_____	AE					

FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
_____	AF		
_____	AG		
_____	AH		
_____	AI		
_____	AJ		

OTHER DOCUMENTS

_____	AK	Nakamura et al.; "POLYIMIDE FILMS PREPARED BY ELECTROPHORETIC DEPOSITION AND THEIR DIELECTRIC BREAKDOWN", SPIE, Volume 2780, pages 71-75, September 11-14, 1995.
_____	AL	
Examiner		Date Considered